

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/751,559	CHEN, PO-JU
	<b>Examiner</b> Lindsay M. Maguire	<b>Art Unit</b> 3634

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
Same as above		3/27/2006	LMM